PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1 Stylesheet Version v1.2 EPAS ID: PAT3327038

SUBMISSION TYPE:	CORRECTIVE ASSIGNMENT
NATURE OF CONVEYANCE:	Corrective Assignment to correct the MISSIN INVENTOR previously recorded on Reel 032007 Frame 0358. Assignor(s) hereby confirms the CORRECTIVE ASSIGNMENT TO CORRECT THE APPLICATION SERIAL NO. 13/119869 PREV. RECORDED ON REEL 031902/FRAME 0120.

CONVEYING PARTY DATA

Name	Execution Date
CHUNLONG LI	11/15/2013
JUNFENG LI	11/15/2013
JIANG YAN	11/15/2013
CHAO ZHAO	11/15/2013

RECEIVING PARTY DATA

Name:	INSTITUTE OF MICROELECTRONICS, CHINESE ACADEMY OF SCIENCES	
Street Address:	eet Address: NO. 3 BEITUCHENG WEST ROAD	
Internal Address:	CHAOYANG DISTRICT	
City:	BEIJING	
State/Country:	CHINA	

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	14119869

CORRESPONDENCE DATA

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ATTORNEY DOCKET NUMBER:	IME-033
NAME OF SUBMITTER:	CE LI
SIGNATURE:	/Ce Li/
DATE SIGNED:	04/27/2015

PATENT 503280420 REEL: 035506 FRAME: 0720

Total Attachments: 5 source=IME033Assignment#page1.tif source=IME033Assignment#page2.tif source=IME033Assignment#page3.tif source=IME033Assignment#page4.tif source=IME033Assignment#page5.tif

PATENT REEL: 035506 FRAME: 0721

ASSIGNMENT

WHEREAS, We/I, Chuntong LI, residing at No.3 Beitucheng West Road, Chaoyang District, Beijing 100029, P.R. China; Junfeng LI, residing at No.3 Beitucheng West Road, Chaoyang District, Beijing 100029, P.R. China; Jiang YAN, residing at 30 Ramona Road, Newburgh, New York 12550, United States of America; and Chao ZHAO, residing at 276 Platte Jostraat Kessel-lo, B-3010, Belgium have invented certain new and useful improvements in and to the subject matter of:

METHOD FOR MANUFACTURING DUMMY GATE IN GATE-LAST PROCESS AND DUMMY GATE IN GATE-LAST PROCESS

described in an application for United States Letters Patent, filed on $\frac{23\text{NOV}2013}{4/119,869}$, and accorded Application No. $\frac{14/119,869}{4/119,869}$;

AND, WHEREAS, INSTITUTE OF MICROELECTRONICS, CHINESE ACADEMY OF SCIENCES, organized under the laws of China, having a place of business located at No. 3 Beitucheng West Road, Chaoyang District, Beijing, China 100029 (hereinafter "ASSIGNEE"), is desirous of acquiring certain rights to the improvements and under the application;

NOW, THEREFORE, in consideration of good and valuable consideration, receipt of which is hereby acknowledged, We/I do hereby sell, assign and transfer unto said ASSIGNEE, its successors, assigns and legal representatives, our/my entire right, title and interest in and throughout the United States of America (including its territories and dependencies) and all countries foreign thereto in and to said improvements, said United States application, any other United States applications, including provisional, divisional, renewal, substitute, continuation, reexamination and reissue applications, based in whole or in part on said United States application or in whole or in part on said improvements, any foreign applications, including international and regional applications, based in whole or in part on any of the aforesaid United States applications or in whole or in part on said improvements, and in and to any and all letters patent, including extensions thereof, of any country which have been or may be granted on any of the aforesaid applications or on said improvements or any parts thereof;

AND We/I hereby authorize and request our/my agents, Goodwin Procter LLP, whose address is 901 New York Ave., N.W.; Washington, DC 20001, to insert hereon any identification necessary or desirable for recordation of this document, including the filing date and application number of said application when known.

AND We/I hereby agree for ourselves/myself and our/my heirs, executors and administrators to execute without further consideration any further documents and instruments which may be necessary, lawful and proper in the prosecution of said above-referenced application or in the preparation or prosecution of any continuing, substitute, divisional, renewal, reexamination or reissue application or in any amendments, extensions or interference proceedings, or other applications for patents of any region or country, that may be necessary to secure to ASSIGNEE its interest and title in and to said improvements or any parts thereof, and in and to said several patents or any of them;

PATENT REEL: 035506 FRAME: 0722 AND We/I hereby covenant for ourselves/myself and our/my legal representatives, and agree with said ASSIGNEE, its successors and assigns, that We/I have granted no right or license to make, use, sell or offer to sell said improvements, to anyone except said ASSIGNEE, that prior to the execution of this deed, our/my right, title and interest in said improvements had not been otherwise encumbered, and that We/I have not and will not execute any instrument in conflict therewith;

AND We/I do hereby authorize and request the Director of the United States Patent and Trademark Office to issue any and all letters patent which may be granted upon said United States applications, or upon said improvements or any parts thereof when granted, to said ASSIGNEE.

IN WITNESS WHEREOF, We/I have hereunto set our/my hands and seals.

1/15/ 4013	である	
Date	Chunlong LI	
On this day of appeared Chunlong LI, to me known ar signed and sealed the foregoing instrumen	na known to me to de	. 2013, before me personally the person of that name, who
deed.	· · · · · · · · · · · · · · · · · · ·	o same to be of this thee act and
	Witnessed by	For Young (Signature)
		Fan YANG (Print Name)
	Witnessed by	Zhoren Fa
		Zhengping FAN (Print Name)

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On this day of November, 2013, before me personally appeared Junseng LI, to me known and known to me to be the person of that name, who signed and sealed the foregoing instrument, and acknowledged the same to be of his free act and deed.
 Witnessed by Fon Young (Signature)
Fan YANG (Print Name)
 Witnessed by Zhenpha Formation (Signature)
Zhengping FAN (Print Name)

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	Date Jiang YAN	<u> </u>
·	On this / day of November appeared Jiang YAN, to me known and known to me to be the peand sealed the foregoing instrument, and acknowledged the same to	_, 2013, before me personally erson of that name, who signed o be of his free act and deed.
* · · · · · · · · · · · · · · · · · · ·	Witnessed by	Fon Young (Signature)
		Print Name)
·.	Witnessed by	Though To (Signature)
		Zhengping FAN (Print Name)
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x .	11/157 3-017 Chao ZHAO	A
	On this day of Nown ber_ appeared Chao ZHAO, to me known and known to me to t signed and sealed the foregoing instrument, and acknowledged deed.	, 2013, before me personally e the person of that name, who the same to be of his free act and
. 75	Witnessed !	oy Fom Youry (Signature)
	Witnessed	Fan YANG (Print Name) by Zhoughing FAN (Brint Name)
al ex	;	(Print Name)

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PATENT REFL: 035506 FRAME: 0726

RECORDED: 04/27/2015 REEL: 035506 FRAME: 0726

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